

# INVENTOR INFORMATION

Inventor One Given Name:: Hideto  
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Postal Address Line One:: c/oSemiconductor Energy Laboratory Co.,Ltd  
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Country:: Japan  
Postal or Zip Code:: 243-0036  
Citizenship Country:: Japan

## CORRESPONDENCE INFORMATION

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## APPLICATION INFORMATION

Title Line One:: METHOD OF MANUFACTURING SEMICONDUCTOR DE  
Title Line Two:: VICE  
Total Drawing Sheets:: 13  
Formal Drawings?: Yes  
Application Type:: Utility  
Docket Number:: 740756-2422  
Secrecy Order in Parent Appl.?: No

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204  
Registration Number One:: 38285  
Registration Number Two:: 35483  
Registration Number Three:: 45285  
Registration Number Four:: 32815  
Registration Number Five:: 26477

## PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2001-019293  
Filing Date:: 01-26-2001  
Country:: Japan  
Priority Claimed:: Yes

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